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	Application No.	Applicant(s)	
	10/791,810	IMAI, YUJI	
Notice of Allowability	Examiner	Art Unit	
	Hung Henry V Nguyen	2851	
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this applied or other appropriate communication IGHTS. This application is subject to	plication. If not include will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to 3/4/2004.			•
2. The allowed claim(s) is/are <u>1-12</u> .			
3. The drawings filed on 04 February 2004 are accepted by the	he Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority ur</li> <li>a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> </ul>			
2.   Certified copies of the priority documents have	e been received in Application No. 09	<u>9/839,202</u> .	
3.  Copies of the certified copies of the priority do	cuments have been received in this	national stage applica	tion from the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the rec	quirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMINER es reason(s) why the oath or declara	'S AMENDMENT or N tion is deficient.	OTICE OF
6. CORRECTED DRAWINGS ( as "replacement sheets") mus	st be submitted.		
(a) including changes required by the Notice of Draftspers		948) attached	
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			back) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT</li> </ol>			lote the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P	atent Application (PT0	)-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6.  Interview Summary	(PTO-413),	,
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 3/04</li> </ol>	Paper No./Mail Dat 98), 7. ☐ Examiner's Amendr		
4. ☐ Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Stateme	ent of Reasons for Allo	wance
of Biological Material	9.	propulari	m
		HENRY HUNG NG	UYER NER

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## **DETAILED ACTION**

## Reasons for Allowance

1. The following is an examiner's statement of reasons for allowance:

- a. Claims 1-7 are allowed because the prior art of record either alone or in combination neither discloses nor makes obvious the combination of a lithography system comprising among other features, a sensor for measuring a state of a development pattern of a photosensitive material after the development of the substrate and along with a judging system with particular function for independently evaluating the performance of the applying apparatus, the exposure apparatus and development apparatus, as recited in the instant claims.
- b. Claims 8-12 are allowed since an exposure apparatus where (1) a first sensor is provided for measuring a physical quantity corresponding to a shape of a pattern of the photosensitive material after development of the substrate; (2) a second sensor is provided for measuring a position of the pattern of the photosensitive material after development of the substrate and (3) a judging system is provided for evaluating a state of the photosensitive material on the substrate based on the detected results of the first sensor and second sensor, is not disclosed in any prior arts of record, and appears to be non-obvious to a person skilled in the art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Prior Art Made of Record

2. The prior art made of record and not relied upon is considered pertinent to applicant's

disclosure.

Ina et al (U.S.Pat. 6,636,311); Hayasaki et al (U.S.Pat. 6,423,977) and Ota (U.S.Pat. 6,057,908)

disclose exposure apparatuses and have been cited for technical background.

3. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Hung Henry V Nguyen whose telephone number is 571-272-

2124. The examiner can normally be reached on Monday-Friday (First Friday off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Judy Nguyen can be reached on 571-272-2258. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hung Henry V Nguyen Primary Examiner

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10/23/04